



Image

1763

Attorney Docket No.: 989_001DIV 1 (now 1153_010 DIV1)

PATENT

UNITED STATES PATENT AND TRADEMARK OFFICE

Inventor(s): James E. Moon, et al.

Serial No.: 10/004,463

Art Unit: 1763

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Title: METHOD FOR FABRICATING MEMS AND
MICROFLUIDIC DEVICES USING LATENT MASKING TECHNIQUE

Mail Stop Patent Application
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

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NOTIFICATION OF CHANGE OF ATTORNEY DOCKET NUMBER

Sir:

Please take note that the attorney docket number for the patent application identified
above has been changed from 989_001DIV 1 to 1153_010DIV 1.

While no fee is believed due with this submission, the Commissioner is hereby
authorized to charge any additional fees associated with this submission, or credit any
overpayment, to Deposit Account No. 50-0289.

Dated: 8.19.03

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